IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

§

In re Application of:

Ganguli et al.

Serial No.: 10/811 230

Confirmation No.: 8995

Filed: March 26, 2004

For: Ruthenium Laver Formation

for Copper Film Deposition

MAIL STOP AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Group Art Unit: 1792

Examiner: Kelly M. Stouffer

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web to the attention of Examiner Kelly M. Stouffer, on the date shown below.

January 14, 2008 Date

Dear Sir:

REQUEST FOR CONTINUED EXAMINATION

This Request for Continued Examination is in response to the Final Office Action dated October 16, 2007, having a shortened statutory period for response set to expire on January 16, 2008, please enter this Request and reconsider the claims pending in the application for reasons discussed below. The attached RCE Transmittal provides the Commissioner with authority to charge the Applicant for the required fees. However, if any additional fees are due in connection with this Request, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/005975.P2/JPC, to make this Request timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. Amendments to the Claims begin on page 3 of this paper. Remarks begin on page 15 of this paper.